



Attorney's Docket No.: 10417-118001 / F51-142893MSW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yoshinori Hino et al. Art Unit : 2826
Serial No. : 10/076,154 Examiner : Tan N. Tran
Filed : February 14, 2002
Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF APRIL 5, 2004

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

August 5, 2004
Date of Deposit
Paula T. Romeo
Signature
PAULA T. ROMEO
Typed or Printed Name of Person Signing Certificate